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AUG 27 2001

## OFFICE OF PETITIONS

NII SOWA LAYE  
850 WEST 41ST STREET  
LOS ANGELES, CA 90037

In re Application of  
Hunt, Deshpande, Hwang, Laye, Oljaca, Shanmugham, Shoup,  
Tomov, Dalzell, Jr., Poda, & Hendrick  
Application No. 09/748,714  
Filed: December 21, 2000  
For: CHEMICAL VAPOR DEPOSITION METHODS FOR MAKING  
POWDERS AND COATINGS, AND COATINGS MADE USING  
THESE METHODS

Dear Mr. Laye:

You are named as a joint inventor in the above identified United States patent application, filed under the provisions of 35 U.S.C. 116 (United States Code), and 37 CFR 1.47(a), Rules of Practice in Patent Cases. Should a patent be granted on the application you will be designated therein as a joint inventor.

As a named inventor you are entitled to inspect any paper in the file wrapper of the application, order copies of all or any part thereof (at a prepaid cost per 37 CFR 1.19) or make your position of record in the application. Alternatively, you may arrange to do any of the preceding through a registered patent attorney or agent presenting written authorization from you. If you care to join in the application, counsel of record (see below) would presumably assist you. Joining in the application would entail the filing of an appropriate oath or declaration by you pursuant to 37 CFR 1.63.

Telephone inquiries regarding this communication should be directed to Karen Creasy at (703)305-8859. Requests for information regarding your application should be directed to the File Information Unit at (703)308-2733. Information regarding how to pay for and order a copy of the application, or a specific paper in the application, should be directed to Certification Division at (703)308-9726 or 1(800)972-6382 (outside the Washington D.C. area).

*Frances Hicks*  
Frances Hicks  
Lead Petitions Examiner  
Office of Petitions  
Office of the Deputy Commissioner  
for Patent Examination Policy

cc:  
MICROCOATING TECHNOLOGIES INC  
5315 PEACHTREE INDUSTRIAL BLVD  
CHAMBLEE, GA 30341



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Paper No. 10

MICROCOATING TECHNOLOGIES INC  
5315 PEACHTREE INDUSTRIAL BLVD  
CHAMBLEE, GA 30341

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**AUG 27 2001**

**OFFICE OF PETITIONS**

In re Application of :  
Hunt, et al : DECISION GRANTING STATUS  
Application No. 09/748,714 : UNDER 37 CFR 1.47(a)  
Filed: December 21, 2000 :  
Attorney Docket No. 0008-FA-US :  
:

This is in response to the petition filed by facsimile transmission on August 16, 2001, requesting reconsideration of the decision mailed August 13, 2001 which refused status under 37 CFR 1.47(a).

The petition is granted.

Petitioner has shown that the non-signing inventor has refused to join in the filing of the above-identified application.

The above-identified application and papers have been reviewed and found in compliance with 37 CFR 1.47(a). This application is hereby accorded Rule 1.47(a) status. As provided in Rule 1.47(c), this Office will forward notice of this application's filing to the non-signing inventor at the address given in the petition. Notice of the filing of this application will also be published in the Official Gazette.

Telephone inquiries regarding this decision should be directed to Karen Creasy at (703) 305-8859.

This application is being forwarded to the Office of Initial Patent Examination.

*Frances Hicks*  
Frances Hicks  
Lead Petitions Examiner  
Office of Petitions  
Office of the Deputy Commissioner  
for Patent Examination Policy